

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MI22-1427SERIAL NO.
09/559,903LIST OF ART CITED BY APPLICANT
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Zhiping Yin et al.FILING DATE
April 26, 2000GROUP
2815

U.S. PATENT DOCUMENTS

| *Examiner Initial | | Document Number | Date | Name | Class | Subclass | Filing Date If Appropriate |
|-------------------|----|-----------------|---------|-------------------|-------|----------|----------------------------|
| <i>gsc</i> | AA | 2001/0038919A1 | 11-2001 | Berry, III et al. | 428 | 446 | Mar. 19, 2001 |
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| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |
| | AK | | | | | | |
| | AL | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | Document Number | Date | Country | Class | Subclass | Translation | |
|------------|----|-----------------|---------|---------|-------|----------|-------------|----|
| | | | | | | | Yes | No |
| <i>gsc</i> | AM | 420844A | 02-2001 | TW | | | | |
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| | AP | | | | | | | |
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

| | | | |
|--|----|--|--|
| | AR | | |
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| | AT | | |

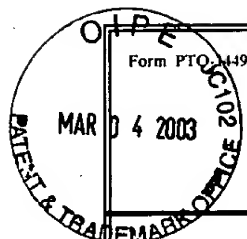
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Form PTO-449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
M122-1427SERIAL NO.
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U.S. PATENT DOCUMENTS

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| JK | AP | 368687A | 09-1999 | TW | - | - | | |
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JK Sheet

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